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		Filing Date December 12, 2003	Group Art Unit: not yet assigned

U.S. PATENT DOCUMENTS

Examiner Initial*	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
<div style="text-align: center;"> 1 </div>	A1	4,720,160	01/19/1988	Hicks, Jr., J. W.		
	A2	5,231,533	07/27/1993	Gnokami, M. et al.		
	A3	5,875,272	02/23/1999	Kewitsch, A. S. et al.		
	A4	5,926,496	07/20/1999	Ho, S.T. et al.		
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	A7	5,952,651	09/14/1999	Morito, Y. et al.		
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Examiner Initial*	Document Number	Date	Name	Class	Subclass	Translation	
						Yes	No
<div style="text-align: center;"> 1 </div>	B1	WO98/53535	11/26/1998			x	
	B2	WO99/39223	08/05/1999			x	
	B3	WO00/29886	05/25/2000			x	
	B4	WO00/35057	06/15/2000			x	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

C1	Cai, M. et al.; "Highly Efficient Optical Power Transfer to Whispering-Gallery Modes by Use of a Symmetrical Dual-coupling Configuration, No. 25, 15 February 2000, Optics Letters; pages 260-262
C2	Cai, M. et al.; "Fiber-Optic Add-Drop Device Based on a Silica Microsphere-Whispering Gallery Mode System", No. 6; June 6, 1999; IEEE Photonics Technology Letters; Pages 686-687
C3	Cai M. et al.; "Observation of Critical Coupling in a Fiber Taper to a Silica-Microsphere Whispering-Gallery Mode System"; Vol. 85, No. 1; July 3, 2000; Physical Review Letters; Dept of Applied Physics; pages 74-77
C4	Chiou, A. E. et al; "Interferometric Optical Tweezers"; No. 133; January 1, 1997; Optics Communications, pages 7-10

Examiner	Date Considered 10/11/05
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*Examiner: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.